

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Mitsuhiro **ICHIJO**, *et al.*) Group Art Unit: 2814
Application No. 10/804,053) Examiner: Long Pham
Filed: March 19, 2004) Confirmation No. 7738
For **FILM FORMATION METHOD AND**)
MANUFACTURING METHOD OF
SEMICONDUCTOR

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AMENDMENT

As part of a Request for Continued Examination (RCE), as submitted herewith, and further to the Advisory Action mailed **October 25, 2006**, and final Official Action mailed **June 28, 2006**, please amend the above-identified patent application, as follows: